ENTERVISION Course – Detectors and Electronics IFIC Valencia, Spain, 9-13 September 2013

# Signal Processing and Electronics

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These course notes are posted together with additional tutorials at http://www-physics.lbl.gov/~spieler

or simply websearch "spieler detectors"

More detailed discussions in H. Spieler: Semiconductor Detector Systems, Oxford University Press, 2005

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# Why understand front-end electronics?



J.Cl. Philippot, IEEE Trans. Nucl. Sci. NS-17/3 (1970) 446

Energy resolution is also important in experiments that don't measure energy.

Energy resolution improves sensitivity because

signal-to-background ratio improves with better resolution.

(signal counts in fewer bins compete with fewer background counts)

In tracking detectors a minimum signal-tobackground ratio is essential to avoid fake hits.

Achieving the required signal-to-noise ratio with minimized power dissipation is critical in large-scale tracking detectors.



G.A. Armantrout et al., IEEE Trans. Nucl. Sci. NS-19/1 (1972) 107

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Recognizing overall contributions to signal sensitivity does not require detailed knowledge of electronics engineering.

It does require a real understanding of basic classical physics.

i.e. recognize which aspects of physics apply in practical situations

... nope, real life doesn't tell you which chapter recipes to follow!

For physicists and electronics engineers to work together efficiently it is necessary that physicists understand basic principles so that they don't request things that cannot work.

A common problem is "wouldn't it be nice to have this ...", which often adds substantial effort and costs

- without real benefits.

Conversely, explaining the physics goals to the engineers is also useful for them to consider alternatives.

I've been asked to teach detector electronics numerous times over the past three decades, but I myself have never taken an electronics course.

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Perhaps it will be useful to see how I learned what to do. I learned this the hard way:

Perhaps this began as I was growing up in a small (~300 inhabitants) town in a traditional farming region in Pennsylvania.

Here it was normal to try to fix your problems yourself and I had many opportunities to construct items I thought of. Historically, this approach was probably driven by past centuries in the Lancaster County: Pennsylvania Dutch Country, Amish + Mennonites

In dealing with old radios that were often sold cheaply, I learned more and at the age of 12 I became a radio amateur and built my own transmitter.

Unfortunately, it didn't work well.

I first tried replacing the antenna, but that didn't help.

Ultimately I did find the problem, but it had not been obvious.

This taught me to think again and again about what I might have done wrong.

Later I helped my grandfather build his new house.

My parents had both come to the U.S. as children. My mother was still in good contact with her uncles in Germany and ultimately this led to my physics study at the Technical University Munich.

Unlike the other university in Munich, the TUM also taught engineering. In Physics the TUM was very scientific and provided a very broad and thorough set of courses in physics.

My first experiments in the late 1960s were in nuclear physics.

Many nuclei are round, but in the mass range 150 < A < 190 they are deformed. For nuclei of the same Z, but different mass, the energies of the first excited states change and the externally measured energy is commonly shifted by temperature and direction..

My experiments were done using the Mössbauer Effect with both source and absorber cooled to 4.2K. In a solid, a fraction of the nuclear events could occur essentially without recoil. This required understanding of both nuclear and solid state physics.

The source was moved sinusoidally by an electromechanical velocity drive to vary the emitted energy and measure the efficiency in the absorber.

Over the year I tracked the changes in core shapes in Os<sup>186</sup>, Os<sup>188</sup>, Os<sup>189</sup>, and Os<sup>190</sup>.

The measurement of Os<sup>190</sup> had not been done before, as the gamma energy was as high as 187 keV, so the detection efficiency with the required energy resolution was critical and individual measurements took up to 4 weeks.

Several measurements were taken simultaneously and the data were stored in a multichannel analyzer. Both scintillator and semiconductor detectors were used.

However, the measurements easily yielded the wrong results. In doing multiple measurements at the same time I found less energy resolution in one system.

Of course, in a complex system one can assume that this is unavoidable, but in investigating all of the components I found that the worse resolution was not due to the experiment system, but due to the analog-to-digital converter. This still happens!

When entering the doctorate work, I was measuring the interactions of heavy-ions.

In order to distinguish the various heavy-ion outputs it was necessary to measure the energy, charge, and mass.

Energy, charge, and atom mass can be measured with two silicon detectors



The original results from a group at another "leading" lab required a  $\Delta E - E$  detector spacing of 1 m, so in addition to my initial on-beam measurements, my main additional task was to develop a large vacuum chamber.

It was also important to improve the minimizing of residual Co in the vacuum, as this led to background signals.

A problem with the 1 m distance to the E detector reduced the effective angle, so the event rate was low.

Increasing the area of the E detector was limited, as its higher capacitance reduced the signal-to-noise ratio and worsened time resolution.

Another effect on time resolution was that the electric distance to the detector edge, i.e. the connection to the electronic front-end, increased, so variations in collection time increased.

In studying the full system, I found that the detectors could actually form signals that are sufficiently fast and have adequate amplitude.

However, our electronics group told me that the required electronics wasn't practical.

In studying electronic preamps in other applications, I found amplifiers that were sufficiently fast with low noise, although designed for other applications.

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I decided to build one. This was very different from my previous radio experience and initial results were not so good.

However, after investigating which components of the circuit could suffer results and how they are connected, preamp performance looked much better.

For example, I found that several capacitors had to be connected with minimal length of wire connections.

Today this is a common procedure, as many components are connected directly without wires, but in those days I had to find capacitors from which I could remove the wires and then mount them directly.

After learning how to recognize what would make the circuit work worse and improve things, the output signals looked fine.

However, the time resolution of the  $\Delta E - E$  system still wasn't as expected.

The problem was the pulse shape discriminator that translates the varying analog pulses to a fixed timing pulse.

The standard setting was to trigger at 20% amplitude. However, this relative level was OK for scintillators, but in looking at my pulse shape, it became clear that the pulse slope was not yet maximum.

Triggering at 40% of the pulse amplitude appeared better and worked.

The result was

 $\Delta t \approx 50 \text{ ps FWHM}$  allowing

20 cm flight path.

**Experimental results:** 

H. Spieler et al., Z. Phys. A278 (1976) 241





I didn't have to build a new big vacuum chamber.

We could accommodate several detector sets in our existing chamber.

This greatly increased the measurement efficiency and also helped my 3 doctorate colleagues to get their results.

An example that later yielded improved results:

1.  $\Delta E$ -detector: 27 µm thick,  $A = 100 \text{ mm}^2$ ,  $\langle E \rangle = 1.1 \cdot 10^4 \text{ V/cm}$ 

2. *E*-detector: 142  $\mu$ m thick,  $A = 100 \text{ mm}^2$ ,  $\langle E \rangle = 2.10^4 \text{ V/cm}$ 

For 230 MeV <sup>28</sup>Si:  $\Delta E = 50 \text{ MeV} \Rightarrow V_S = 5.6 \text{ mV}$  $E = 180 \text{ MeV} \Rightarrow V_S = 106 \text{ mV}$ 

$$\Rightarrow \quad \Delta t = 32 \text{ ps FWHM} \\ \sigma_t = 14 \text{ ps}$$

This again indicates that good experiments require not just the understanding of the physics goals, but also the constraints of the measurement equipment and understanding their physics.  $\Rightarrow$  This can often yield more physics data.

In the following decades I often changed my physics goals, as I was always interested in learning something new, rather than working deeper in the same area.

In the early 1980s a conference discussing new detectors for high-energy particle physics concluded that given the energy and data rate, position detectors were not practical.

When I heard this, based on my efforts for a position detector in an astronomy proposal and studying the experimental requirements, I concluded that semiconductor strip and pixel detectors could be quite practical and triggered the appropriate R&D at LBL.

This was new for both the scientists and engineers, but became very successful for the first semiconductor detector at the CDF at Fermilab, internationally the first high-rate detector at high-energy proton accelerator. It required simultaneous signal taking and readout.

Development of ICs with the special requirements was critical and a new process. Fortunately, I could acquire engineers with an appropriate background.

Following developments contributed to both the strip and pixel detectors for the highresolution tracking detectors in the ATLAS detector at CERN.

Radiation damage was also a critical consideration.

I was active in performing test-beam measurements to verify performance and also recognize potential problems.

As part of the team that organized test-beam measurements for the various groups working on the semiconductor tracking detectors for ATLAS, I could also view a range of different aspects. Actively collaborating with UC Santa Cruz was also very helpful. When mass production began, rather than being pulled into engineering by our upper project organizer, I shifted my interest into astronomy (an area I had already worked on in the 1980s) and came up with a new measurement system for the planned South Pole Telescope.

Measurements with good position resolution at frequencies of about 150 GHz yield data when atoms were first formed about 300 000 years after the universe formation about 13 to 14 million years ago. Our data follow the initial formation of planets.

The data from about 1000 detectors was taken continuously and read out without interruptions.

This was done by having the data modulate a carrier, as in radio amplitude modulation.

Within detector groups each detector was biased with a different frequency, so all signals could be sent simultaneously through the same line.

The detectors are linked to a temperature of about 0.25K, so designing the coupling to the front end at 4.2K was critical, both to maintain temperature coupling and series inductance at acceptable levels.

# **Thermal Detectors**

If all absorbed Energy E is converted into phonons, the temperature of the sample will increase by

$$\Delta T=rac{E}{C}$$
 ,

where C is the heat capacity of the sample (specific heat x mass).

A superconducting material will yield a larger change in resistance for a small temperature change, so this is the desirable operation energy.



Resistance ( $\Omega$ )

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# South Pole Telescope

10m diameter parabolic reflector with off-axis feed

~25 micron surface accuracy

Beamwidth: 1.3 arcmin

1 deg field of view

Maximum scan speed: 4 deg/s

100% observing time

9300 ft altitude

Funded by NSF Polar Programs

First observations in 2007 – many results since then.

For a better description go to my website www-physics.lbl.gov/~spieler



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Here it was important to attract engineers who have experience in developing large-scale detectors, i.e. not in astronomy but in high-energy physics.

At LBL my support had to come from the U.S. Department of Energy. When the project seemed to be functional, DoE support was cut. I still spent my own time to continue, but also got into another project development:

High-Pressure Xe TPC: A detector that yields both energy and positions. (returning me to studies in the late 1970s and early 80s)

Potential Applications

- 1. Search for neutrinoless double-beta decay
  - a) Verify that the neutrino is its own anti-particle
  - b) Helps determine absolute neutrino mass
  - c) If observed, lepton number not conserved
- 2. Large-area gamma detectors that require background suppression

High-pressure Xe gas can provide energy resolution much superior to liquid Xe.

 $E = 2.5 \text{ MeV} (= Q^{136} \text{Xe})$ :

- High-Pressure Xe:  $\Delta E / E \approx 3.10^{-3}$  (Fano factor  $\approx 0.15$ )
- Liquid Xe (EXO prediction):  $\Delta E / E \approx 35 \cdot 10^{-3}$  (Fano factor  $\approx 20$ )

Q-value (136Xe  $\rightarrow$  136Ba) = 2480 keV

$$\frac{\Delta E}{Q} = 2.35 \cdot \frac{\sqrt{FN}}{Q} = 2.35 \cdot \sqrt{\frac{FW}{Q}} \approx 2.9 \cdot 10^{-3} \text{ FWHM}$$

W = energy per ion/electron pair in xenon gas = 21.9 eV, but *W* depends on electric field strength, might be ~24.8 eV

N = number of ion pairs = Q/W

F = Fano factor. Measured in Xe gas: F = 0.13 - 0.17 (assume 0.15)

Comparison:

Germanium diodes @ 2.5 MeV $\Delta E / E \approx 1 - 2 \cdot 10^{-3}$  FWHMFano Factor of Liquid Xe ~20  $\Rightarrow$  $\Delta E / E \approx 3.5 \cdot 10^{-2}$  FWHM

Electroluminescence

Accelerate electrons in an electric field so that over a certain distance they gain just enough energy to excite optical states – NOT emit secondary electrons.

 $\Rightarrow$  This reduces statistic number fluctuations

With a voltage span of 40 kV over the 8 cm active test range, both mechanical and electronic issues were critical.

Overall, common to all of these (and other) experimental measurements I considered:

- 1. Understand the experiment physics goals and consider potential variation to the common techniques.
- 2. Experiments that were not possible with conventional detection and data taking, that science area may well be possible with different data components and detecting systems.

It is important to understand the

- 1. Science goals and constraints
- 2. Basic physics of the detection systems

Coupling the science goals with practical engineering can yield very successful results.

In all measurements it is important to understand the limits of the measurement system.

I have seen people claiming physics based on measurements that provided results, but not what they thought.

Given my consideration of what may go wrong in the practical development and also in experimental results, I was often led to doing the additional work myself.

Although this general approach has been very successful, it also has its drawbacks:

Many physicists think that practical applications are a matter of engineering, so often I no longer could pursue the science I was aiming at.

I certainly am not capable of doing much of the work that engineers can handle.

However, because I can understand the applications and often participate in the design, many physicists in Berkeley call me an engineer and treat me like a technician, expecting me to do the application work.

As a result, I didn't get the appropriate support.

Nevertheless, I still urge scientists to understand the application of physics and to explain the experimental goals to the engineers.

For both it is important to understand the basics and not just follow the recipes.

It truly is helpful in doing good measurements and interpreting the results.

Overall, it is very useful to view the complete system and check the assumed functions.

This is useful in a wide range of topics.

With my German name and getting my doctorate in Germany leads many to say that I am German (especially theorists).

However, I've been a U.S. citizen all of my life, was born in the U.S. and that's where I grew up. And my parents had come to the U.S. in their youth and grew up as U.S. citizens.

So, before jumping to a conclusion, it is always good to check the facts.

P.S. There are some really good physics theorists, but many theorists are highly specialized and driven by their narrow vision.

### Let's look at electronic systems and their basics.

What Determines Sensitivity or Resolution?

1. Signal variance (e.g. statistical fluctuations) >> Baseline Variance



#### $\Rightarrow$ Electronic (baseline) noise not important

Examples: • High-gain proportional chambers

• Scintillation Counters with High-Gain PMTs

e.g. 1 MeV  $\gamma$ -rays absorbed by NaI(Tl) crystal Number of photoelectrons:  $N_{pe} \approx 8.10^4 \, [\text{MeV}^{-1}] \times E_{\gamma} \times QE \approx 2.4.10^4$ Variance typically:  $\sigma_{pe} = N_{pe}^{1/2} \approx 160 \text{ and } \sigma_{pe} / N_{pe} \approx 5 - 8\%$ Signal at PMT anode (assume Gain= 10<sup>4</sup>):  $Q_{sig} = G_{PMT} N_{pe} \approx 2.4.10^8 \text{ el}$   $\sigma_{sig} = G_{PMT} \sigma_{pe} \approx 1.2.10^7 \text{ el}$ whereas electronic noise easily < 10<sup>4</sup> el

# 2. Signal Variance << Baseline Variance SIGNAL \* BASELINE NOISE $\Rightarrow$ SIGNAL + NOISE BASELINE BASELINE BASELINE BASELINE BASELINE

 $\Rightarrow$  Electronic (baseline) noise critical for resolution

- Examples: Gaseous ionization chambers (no internal gain)
  - Semiconductor detectors

e.g. in Si : Number of electron-hole pairs 
$$N_{ep} = \frac{E_{dep}}{3.6 \text{ eV}}$$
  
Variance  $\sigma_{ep} = \sqrt{F \cdot N_{ep}}$  (where  $F =$  Fano factor  $\approx 0.1$ )  
For 50 keV photons:  $\sigma_{ep} \approx 40 \text{ el} \Rightarrow \sigma_{ep} / N_{ep} = 7.5 \cdot 10^{-4}$ 

Obtainable noise levels are 10 to 1000 el.

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Baseline fluctuations can have many origins ...

pickup of external interference

artifacts due to imperfect electronics

... etc.,

but the (practical) fundamental limit is electronic noise.

Depends on noise sources and signal processing.

Sources of electronic noise: • Thermal fluctuations of carrier motion

• Statistical fluctuations of currents

Both types of fluctuations are random in amplitude and time

- $\Rightarrow$  Power distributed over wide frequency range
- $\Rightarrow$  Contribution to energy fluctuations depends on signal processing

Many different types of detectors are used for radiation detection.

Nearly all rely on electronics.

Although detectors appear to be very different, basic principles of the readout apply to all.

- The sensor signal is a current.
- The integrated current  $Q_S = \int i_S(t) dt$  yields the signal charge.
- The total charge is proportional to the absorbed energy.

Readout systems include the following functions:

- Signal acquisition
- Pulse shaping
- Digitization
- Data Readout

Example: Scintillation Detector



#### Readout



charge in pulsepulse height $\infty$  absorbed energy $\infty$  absorbed energy

#### **Basic Functions of Front-End Electronics**



Pulse shaping can also be performed with digital circuitry:



## Many Different Implementations

"Traditional" Si detector system for charged particle measurements



# Tracking Detector Module (CDF SVX) 512 electronics channels on 50 μm pitch





## ATLAS Silicon Strip system (SCT): 128-Channel chips mounted on hybrid

Design criteria depend on application

- 1. Energy resolution
- 2. Rate capability
- 3. Timing information
- 4. Position sensing

#### Large-scale systems impose compromises

- 1. Power consumption
- 2. Scalability
- 3. Straightforward setup + monitoring
- 4. Cost

#### Technology choices

- 1. Discrete components low design cost fix "on the fly"
- 2. Full-custom ICs high density, low power, but better get it right!

Successful systems rely on many details that go well beyond "headline specs"!

- II. Signal Formation and Acquisition
- 1. Photomultipliers

## **Basic Function**



Voltage applied between dynodes accelerates the electrons to yield a significant gain.

The final set of electrons is collected by the anode and yields the output signal.

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#### A common configuration:



It is important to follow the individual currents

In the final dynodes the signal current can be so large that the voltage drop across the resistor is excessive.

The capacitors connected to the final dynodes are to store sufficient charge to avoid a significant voltage change.

# The previous arrangement is typical, but it can be done better:



Connecting the storage capacitors directly between the dynodes provides a direct current path.

The smaller voltage across the capacitors also makes larger capacitances more practical, e.g. 1  $\mu$ F multi-layer ceramic chip capacitors.

 $\Rightarrow$  Less dynode-dynode voltage drop per pulse

Having the anode at ground level allows direct connection to the signal cable, often referred to as "DC coupling". However, it really isn't ...

#### Detail of output circuit

The output current loop always passes through the capacitor to the last dynode.



Placing the anode at ground level reduces the voltage on the final dynode relative to ground.

This allows a larger capacitance, increasing the time constant of the output coupling.

The larger signal currents at the last dynodes can reduce the dynamic range at high rates.

Electronic circuits that stabilize the voltage across individual dynodes can maintain the gain at high rates and can also provide true DC coupling of the output signal.



A simpler solution is to run the PMT at lower overall gain and adding a preamplifier.

• Fast low-noise amplifiers are quite practical.

The first dynode gain should still be kept high, but especially the final dynodes can run at much lower gain. PMTs with fewer dynode stages would be best.

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### Signal Fluctuations in a Scintillation Detector

Example: Scintillation Detector - a typical NaI(TI) system (from Derenzo)

Resolution of energy measurement is determined by the statistical variance of produced signal quanta.

$$\frac{\Delta E}{E} = \frac{\Delta N}{N} = \frac{\sqrt{N}}{N} = \frac{1}{\sqrt{N}}$$

# Resolution is determined by the smallest number of quanta in the chain,

i.e. number of photoelectrons arriving at the first dynode.

In this example

 $\frac{\Delta E}{E} = \frac{1}{\sqrt{3000}} = 2\% \text{ rms} = 5\% \text{ FWHM}$ 

511 keV gamma ray ↓ 25000 photons in scintillator ↓ 15000 photons at photocathode ↓ 3000 photoelectrons at first dynode ↓ 3 10<sup>9</sup> electrons at anode 2 mA peak current

Typically 7 – 8% obtained, due to non-uniformity of light collection and gain.

2. Semiconductor Detectors

## Signal Formation



When does the signal current begin?

a) when the charge reaches the electrode?

or

b) when the charge begins to move?

Although the first answer is quite popular (encouraged by the phrase "charge collection"), the second is correct.

When a charge pair is created, both the positive and negative charges couple to the electrodes.

As the charges move the induced charge changes, i.e. a current flows in the electrode circuit.

# The electric field of the moving charge couples to the individual electrodes and determines the induced signal.

The following discussion applies to ALL types of structures that register the effect of charges moving in an ensemble of electrodes, i.e. not just semiconductor or gas-filled ionization chambers, but also resistors, capacitors, photoconductors, vacuum tubes, etc.

The effect of the amplifier on the signal pulse will be discussed in the Electronics part.

#### Induced Charge

Consider a charge q in a parallel plate capacitor:

When the charge is midway between the two plates, the charge induced on one plate is determined by applying Gauss' law. The same number of field lines intersect both  $S_1$  and  $S_2$ , so equal charge is induced on each plate ( = q / 2).

When the charge is close to one plate, most of the field lines terminate on that plate and the induced charge is much greater.



As a charge traverses the space between the two plates the induced charge changes continuously, so current flows in the external circuit as soon as the charges begin to move.

## Induced Signal Currents in a Strip or Pixel Detector

Consider a charge originating near the upper contiguous electrode and drifting down towards the strips.



Initially, charge is induced over many strips.

As the charge approaches the strips, the signal distributes over fewer strips. When the charge is close to the strips, the signal is concentrated over few strips

The magnitude of the induced current due to the moving charge depends on the coupling between the charge and the individual electrodes.

Mathematically this can be analyzed conveniently by applying Ramo's theorem. (Chapter 2, pp 71-82)

# Note that deriving induced charge from "energy conservation" generally yields wrong results (it's typically not a theory based on the relevant physics).

#### Current pulses in strip detectors (track traversing the detector)



The duration of the electron and hole pulses is determined by the time required to traverse the detector as in a parallel-plate detector, but the shapes are very different.



For comparison:

Current pulses in pad detectors (track traversing the detector)



For the same depletion and bias voltages the pulse durations are the same as in strip detectors, although the shapes are very different.

Overbias decreases the collection time.

Varying time delays in signal amplitude can affect timing measurements.

The coupling of the charge increases greatly when the charge comes close to the electrode in strip or pixel detectors.



a) Visible light (energies near band gap)

Detection threshold = energy required to produce an electron-hole pair ≈ band gap

In indirect bandgap semiconductors (Si), additional momentum is required: provided by phonons



(from Sze, Semiconductor Physics)

b) High energy quanta ( $E \gg E_g$ )

It is experimentally observed that the energy required to form an electron-hole pair exceeds the bandgap.

In Si:  $E_i = 3.6 \text{ eV} (E_g = 1.1 \text{ eV})$ 

Why?

When particle deposits energy one must conserve both

energy and momentum

momentum conservation is not fulfilled by transition across the gap

⇒ excite phonons (lattice vibrations, i.e. heat)



A. Klein, J. Applied Physics 39 (1968) 2029

Signal Fluctuations: Intrinsic Resolution of Semiconductor Detectors

$$\Delta E_{\rm FWHM} = 2.35 \cdot E_i \ \sqrt{FN_Q} = 2.35 \cdot E_i \sqrt{F \frac{E}{E_i}} = 2.35 \cdot \sqrt{FEE_i}$$

F is the Fano factor, which inherently reduces statistical fluctuations.

Si: 
$$E_i = 3.6 \text{ eV}$$
  $F = 0.1$   
Ge:  $E_i = 2.9 \text{ eV}$   $F = 0.1$ 

The Fano factor is small in Si and Ge, because a large portion of the energy adds phonons with a much smaller (~meV) excitation level (Chapter 2, pp 52-55).

For comparison, in liquid Xenon  $F \approx 20$ , whereas in Xe gas  $F \approx 0.15$ .

#### Inherent Detector Energy Resolution



Detectors with good efficiency in the 10s of keV range can have sufficiently small capacitance to allow electronic noise of ~100 eV FWHM, so the variance of the detector signal is a significant contribution.

At energies >100 keV the detector sizes required tend to increase the electronic noise to dominant levels.

In addition to energy measurements, semiconductor detectors allow precision position sensing.

Resolution determined by precision of micron scale patterning of the detector electrodes.



Pixel detectors yield 2-dimensional resolution.

More electronics required, but usually practical at the same total energy per unit area.

3. Signal Acquisition

Amplifier Types

a) Voltage-Sensitive Amplifier

The signal voltage at the amplifier input

$$v_i = \frac{R_i}{R_S + R_i} v_S$$



If the signal voltage at the amplifier input is to be approximately equal to the signal voltage

$$v_i \approx v_S \quad \Rightarrow \quad R_i \gg R_S$$

To operate in the voltage-sensitive mode, the amplifier's input resistance (or impedance) must be large compared to the source resistance (impedance).

In ideal voltage amplifiers one sets  $R_i = \infty$ 

This is never true in reality, although it can be fulfilled to a good approximation.

To provide a voltage output, the amplifier should have a low output resistance, i.e. its output resistance should be small compared to the input resistance of the following stage.

#### b) Current-Sensitive Amplifier

The signal current divides into the source resistance and the amplifier's input resistance. The fraction of current  $i_S$  flowing into the amplifier

$$\dot{i_i} = \frac{R_s}{R_s + R_i} \dot{i_S}$$



If the current flowing into the amplifier is to be approximately equal to the signal current

$$i_i \approx i_S \quad \Rightarrow \quad R_i \ll R_S$$

To operate in the current-sensitive mode, the amplifier's input resistance (or impedance) must be small compared to the source resistance (impedance).

One can also model a current source as a voltage source with a series resistance. For the signal current to be unaffected by the amplifier input resistance, the input resistance must be small compared to the source resistance, as derived above.

At the output, to provide current drive the output resistance should be high, i.e. large compared to the input resistance of the next stage.

- Whether a specific amplifier operates in the current or voltage mode depends on the source resistance.
- Amplifiers can be configured as current mode input and voltage mode output or, conversely, as voltage mode input and current mode output. The gain is then expressed as V/A or A/V.

Although an amplifier has a pair of input and a second pair of output connections, since the two have a common connection a simplified representation is commonly used:



c) Voltage and Current Mode with Capacitive Sources



Operating mode depends on charge collection time  $t_c$  and the input time constant  $R_iC_d$ :

a)  $R_i C_d \ll t_c$ detector capacitance discharges rapidly  $\Rightarrow v_o \propto i_s(t)$ 

current sensitive amplifier

b)  $R_i C_d \gg t_c$ detector capacitance discharges slowly  $\Rightarrow v_o \propto \int i_s(t) dt$ voltage sensitive amplifier

Note that in both cases the amplifier is providing voltage gain, so the output signal voltage is determined directly by the input voltage. The difference is that the shape of the input voltage pulse is determined either by the instantaneous current or by the integrated current and the decay time constant.

Goal is to measure signal charge, so it is desirable to use a system whose response is independent of detector capacitance.

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Active Integrator ("charge-sensitive amplifier")



 $Q_i$  is the charge flowing into the preamplifier .... but some charge remains on  $C_d$ .

What fraction of the signal charge is measured?

Example:

$$\frac{Q_i}{Q_s} = \frac{C_i v_i}{Q_d + Q_i} = \frac{C_i}{Q_s} \cdot \frac{Q_s}{C_i + C_d}$$

$$= \frac{1}{1 + \frac{C_d}{C_i}} \approx 1 \quad (\text{if } C_i >> C_d)$$

$$A = 10^3$$

$$C_f = 1 \text{ pF} \implies C_i = 1 \text{ nF}$$

$$C_{det} = 10 \text{ pF}: \qquad Q_i / Q_s = 0.99$$

$$C_{det} = 500 \text{ pF}: \qquad Q_i / Q_s = 0.67$$

$$\uparrow$$
Si Det.: 50 µm thick, 250 mm<sup>2</sup> area

Note: Input coupling capacitor must be  $\gg C_i$  for high charge transfer efficiency.

#### Calibration

Inject specific quantity of charge - measure system response

Use voltage pulse (can be measured conveniently with oscilloscope)



 $C_i >> C_T \implies$  Voltage step applied to test input develops over

$$\Rightarrow \qquad Q_T = \Delta V \cdot C_T$$

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### **Realistic Charge-Sensitive Preamplifiers**

The preceding discussion assumed idealized amplifiers with infinite speed.

In reality, amplifiers may be too slow to follow the instantaneous detector pulse.

Does this incur a loss of charge?



# Signal is preserved even if the amplifier responds much more slowly than the detector signal.

However, the response of the amplifier affects the measured pulse shape.

- How do "real" amplifiers affect the measured pulse shape?
- How does the detector affect amplifier response?

#### A Simple Amplifier



Voltage gain: 
$$A_V = \frac{dv_o}{dv_i} = \frac{di_o}{dv_i} \cdot Z_L \equiv g_m Z_L$$

 $g_m \equiv$  transconductance

$$Z_L = R_L / / C_o$$
$$\frac{1}{Z_L} = \frac{1}{R_L} + \mathbf{i}\omega C_o$$



Note: **i** indicates the 90° phase shift between capacitor voltage and current Frequency and phase response:



Phase shows change from low-frequency response. For an inverting amplifier add 180°.

The corner (cutoff) frequency is often called a "pole".

#### Pulse Response of the Simple Amplifier

A voltage step  $v_i(t)$  at the input causes a current step  $i_o(t)$  at the output of the transistor. For the output voltage to change, the output capacitance  $C_o$  must first charge up.

 $\Rightarrow$  The output voltage changes with a time constant  $\tau = R_L C_O$ 



The time constant  $\tau$  corresponds to the upper cutoff frequency :  $\tau = \frac{1}{2\pi f_{u}}$ 

#### Input Impedance of a Charge-Sensitive Amplifier

Input impedance

$$Z_i = \frac{Z_f}{A+1} \approx \frac{Z_f}{A} \quad (A >> 1)$$

Amplifier gain vs. frequency beyond the upper cutoff frequency

 $A = -\mathbf{i} \frac{\omega_0}{\omega}$  $Z_f = -\mathbf{i} \frac{1}{\omega C_f}$ 

Feedback impedance

 $\Rightarrow$ 

Input Impedance

$$Z_i = -\frac{\mathbf{i}}{\omega C_f} \cdot \frac{1}{-\mathbf{i} \frac{\omega_0}{\omega}} = \frac{1}{\omega_0 C_f}$$



Gain-Bandwidth Product

Imaginary component vanishes $\Rightarrow$ Resistance:  $Z_i \rightarrow R_i$  $\Rightarrow$ low frequencies ( $f < f_u$ ): capacitive input<br/>high frequencies ( $f > f_u$ ): resistive input

Practically all charge-sensitive amplifiers operate in the 90° phase shift regime.  $\Rightarrow$  Resistive input However ... Note that the input impedance varies with frequency.

Example: cutoff frequencies at 10 kHz and 100 MHz, low frequency gain =  $10^3$ 



In the resistive regime the input impedance

$$Z_i=\!\frac{1}{\omega_{\!\scriptscriptstyle 0}C_f}$$
 ,

where  $C_f$  is the feedback capacitance and  $\omega_0$  is the extrapolated unity gain frequency in the 90° phase shift regime.



Time Response of a Charge-Sensitive Amplifier

Input resistance and detector capacitance form RC time constant:

Rise time increases with detector capacitance.

Closed Loop Gain  $A_f = \frac{C_D + C_f}{C_f} \quad (A_f << A_0)$  $A_f \approx \frac{C_D}{C_f} \quad (C_D >> C_f)$ 

Or apply feedback theory:

Closed Loop Bandwidth  $\omega_C A_f = \omega_0$ 

**Response Time** 

$$\tau_{amp} = \frac{1}{\omega_C} = C_D \ \frac{1}{\omega_0 C_f}$$

Same result as from input time constant.







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Importance of input impedance in strip and pixel detectors:

Amplifiers must have a low input impedance to reduce transfer of charge through capacitance to neighboring strips

In the previous example at 8 MHz ( $\triangleq$  ~20 ns peaking time)  $Z_i \approx$ 1.6 k $\Omega$ , corresponding to 12 pF  $_{\text{DETECTOR}}^{\text{STRIP}}$ 

 $\Rightarrow$  with 6 cm long strips about half of the signal current will go to the neighbors.



For strip pitches that are smaller than the bulk thickness, the capacitance is dominated by the fringing capacitance to the neighboring strips  $C_{SS}$ .

Typically: 1 - 2 pF/cm for strip pitches of  $25 - 100 \text{ }\mu\text{m}$  on Si.

The backplane capacitance  $C_b$  is typically 20% of the strip-to-strip capacitance.

Negligible cross-coupling at shaping times  $T_P > (2 \dots 3) \times R_i C_D$  and if  $C_i \gg C_D$ .

## **III. Electronic Noise**

Choose a time when no signal is present.

Amplifier's quiescent output level (baseline):

In the presence of a signal, noise + signal add.





Measurement of peak amplitude yields signal amplitude + noise fluctuation

The preceding example could imply that the fluctuations tend to increase the measured amplitude, since the noise fluctuations vary more rapidly than the signal.

In an optimized system, the time scale of the fluctuation is comparable to the signal peaking time.

Then the measured amplitude fluctuates positive and negative relative to the ideal signal.



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Electronic noise is purely random.

- ⇒ amplitude distribution is Gaussian
- $\Rightarrow$  noise modulates baseline
- ⇒ baseline fluctuations superimposed on signal
- ⇒ output signal has Gaussian distribution



#### Measuring Resolution

Inject an input signal with known charge using a pulse generator set to approximate the detector signal shape.

peak centroid $\Rightarrow$ signal magnitudepeak width $\Rightarrow$ noise (FWHM= 2.35  $Q_n$ )

#### **Basic Noise Mechanisms and Characteristics**

Consider *n* carriers of charge *e* moving with a velocity v through a sample of length *l*. The induced current *i* at the ends of the sample is

$$i = \frac{n \ e \ v}{l}$$

The fluctuation of this current is given by the total differential

$$\langle di \rangle^2 = \left(\frac{ne}{l} \langle dv \rangle\right)^2 + \left(\frac{ev}{l} \langle dn \rangle\right)^2$$

where the two terms are added in quadrature since they are statistically uncorrelated.

Two mechanisms contribute to the total noise:

- velocity fluctuations, *e.g.* thermal noise
- number fluctuations, *e.g.* shot noise excess or "1/ f" noise

Thermal noise and shot noise are both "white" noise sources, i.e.

power per unit bandwidth (= spectral density) is constant:

$$\frac{dP_{noise}}{df} = const.$$

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## 1. Thermal Noise in Resistors

The most common example of noise due to velocity fluctuations is the thermal noise of resistors.

Noise power density vs. frequency  $f: \frac{dP_{noise}}{df} = 4kT$  k = Boltzmann constant

T = absolute temperature

R = DC resistance

since  $P = \frac{V^2}{R} = I^2 R$ 

the spectral noise voltage density

 $\frac{dV_{noise}^2}{df} \equiv e_n^2 = 4kTR$  $\frac{dI_{noise}^2}{df} \equiv i_n^2 = \frac{4kT}{R}$ 

and the spectral noise current density

The total noise depends on the bandwidth of the system.

For example, the total noise voltage at the output of a voltage amplifier with the frequency dependent gain  $A_v(f)$  is

$$v_{on}^2 = \int_0^\infty e_n^2 A_v^2(f) df$$

Note: Since spectral noise components are not correlated, one must integrate over the noise power (proportional to voltage or current squared).

Total noise increases with bandwidth.


# 2. Shot noise

A common example of noise due to number fluctuations is "shot noise", which occurs whenever carriers are injected into a sample volume independently of one another.

Example: current flow in a semiconductor diode (emission over a barrier)

Spectral noise current density:  $i_n^2 = 2eI$  e = electronic chargeI = DC current

When measuring signal charge the signal pulses are integrated over time. The shot noise then results from the statistical fluctuations of total number of injected carriers during the integration time, so the noise increases with the square root of shaping time.

*Note:* Shot noise does not occur in "ohmic" conductors. Since the number of available charges is not limited, the fields caused by local fluctuations in the charge density draw in additional carriers to equalize the total number.

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# 3. Low Frequency ("1/f") Noise

Charge can be trapped and then released after a characteristic lifetime  $\tau$ .

The spectral density for a single lifetime

$$S(f) \propto rac{ au}{1 + (2\pi f au)^2} \; .$$

For 
$$2\pi f \tau \gg 1$$
:  $S(f) \propto \frac{1}{f^2}$ 

However,

several traps with different time constants can yield a "1/f" distribution:

Traps with three time constants of 0.01, 0.1 and 1 s yield a 1/f distribution over two decades in frequency.

Low frequency noise is ubiquitous – must not have 1/f dependence, but commonly called 1/f noise.

Spectral power density:  $\frac{dP_{noise}}{df} = \frac{1}{f^{\alpha}}$  (typically  $\alpha = 0.5 - 2$ )



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#### 4. Noise Bandwidth vs. Signal Bandwidth

Consider an amplifier with the frequency response A(f). This can be rewritten

 $A(f) \equiv A_0 G(f),$ 

where  $A_0$  is the maximum gain and G(f) describes the frequency response.

For example, for the simple amplifier described above

$$A_{v} = g_{m} \left( \frac{1}{R_{L}} + \mathbf{i}\omega C_{o} \right)^{-1} = g_{m}R_{L} \frac{1}{1 + \mathbf{i}\omega R_{L}C_{o}}$$

and using the above convention  $A_0 \equiv g_m R_L$  and  $G(f) \equiv \frac{1}{1 + \mathbf{i} (2\pi f R_L C_o)}$ 

If a "white" noise source with spectral density  $e_{ni}$  is present at the input, the total noise voltage at the output is

$$v_{no} = \sqrt{\int_{0}^{\infty} e_{ni}^{2} |A_{0}G(f)|^{2} df} = e_{ni} A_{0} \sqrt{\int_{0}^{\infty} G^{2}(f) df} \equiv e_{ni} A_{0} \sqrt{\Delta f_{n}}$$

 $\Delta f_n$  is the "noise bandwidth".

Note that, in general, the noise bandwidth and the signal bandwidth are not the same.

If the upper cutoff frequency is determined by a single *RC* time constant, as in the "simple amplifier",

the signal bandwidth 
$$\Delta f_s = f_u = \frac{1}{2\pi RC}$$

and the noise bandwidth

$$\Delta f_n = \frac{1}{4RC} = \frac{\pi}{2} f_u \quad .$$

# Noise Bandwidth and Low Frequency (1/*f*) Noise

For a spectral noise density

$$P_{nf} = \frac{S_f}{f}$$

 $e_{nf}^2 = \frac{A_f}{c}$ 

and a corresponding voltage density

the total noise integrated in a frequency band  $f_1$  to  $f_2$  is

$$v_{nf}^2 = \int\limits_{f_1}^{f_2} rac{A_f}{f} \ df = A_f \log \left(rac{f_2}{f_1}
ight)$$

Thus, for a 1/f spectrum the total noise depends on the ratio of the upper to lower cutoff frequency.

Since this is a power distribution, the voltage or current spectral density changes 10-fold over a 100-fold span in frequency.

Frequently, the 1/f noise corner is specified: frequency where 1/f noise intercepts white noise.

Higher white noise level reduces the corner frequency, so a lower noise corner does not equate to lower 1/f noise.

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# "Noiseless" Resistance Example – Dynamic Resistance

In many instances a resistance is formed by the slope of a device's current-voltage characteristic, rather than by a static ensemble of electrons agitated by thermal energy.

Example: forward-biased semiconductor diode

Diode current vs. voltage  $I = I_0(e^{q_e V/kT} - 1)$ 

The differential resistance

$$r_d = \frac{dV}{dI} = \frac{kT}{q_e I}$$

i.e. at a given current the diode presents a resistance, e.g. 26  $\Omega$  at I = 1 mA and T = 300 K.

Note that two diodes can have different charge carrier concentrations, but will still exhibit the same dynamic resistance at a given current, so the dynamic resistance is not uniquely determined by the number of carriers, as in a resistor.

There is no thermal noise associated with this "dynamic" resistance, although the current flow carries shot noise.

#### Noise in Amplifier Chains

Consider a chain of two amplifiers (or amplifying devices), with gains  $A_1$  and  $A_1$ , and input noise levels  $N_1$  and  $N_2$ .

A signal *S* is applied to the first amplifier, so the input signal-to-noise ratio is  $S/N_1$ .



At the output of the first amplifier the signal is  $A_1S$  and the noise  $A_1N$ .

Uncorrelated noise components add in quadrature, e.g.  $V_{n,tot} = \sqrt{\sum_{i} V_{ni}^2}$ 

Both are amplified by the second amplifier, but in addition the second amplifier contributes its noise, so the signal-to-noise ratio at the output of the second amplifier

$$\left(\frac{S}{N}\right)^2 = \frac{\left(SA_1A_2\right)^2}{\left(N_1A_1A_2\right)^2 + \left(N_2A_2\right)^2} = \frac{S^2}{N_1^2 + \left(\frac{N_2}{A_1}\right)^2} = \left(\frac{S}{N_1}\right)^2 \frac{1}{1 + \left(\frac{N_2}{A_1N_1}\right)^2}$$

The overall sign-to-noise ratio is reduced, but the noise contribution from the second-stage can be negligible, provided the gain of the first stage is sufficiently high.

 $\Rightarrow$  In a well-designed system the noise is dominated by the first gain stage.

5. Signal-to-Noise Ratio vs. Detector Capacitance



if  $R_i \times (C_{det} + C_i) \gg$  collection time,

peak voltage at amplifier input 
$$V_{in} = \frac{Q_s}{C} = \frac{\int i_s dt}{C} = \frac{Q_s}{C_{det} + C_i}$$

Magnitude of voltage depends on total capacitance at input!

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The peak amplifier signal  $V_s$  is inversely proportional to the **total capacitance at the input**, i.e. the sum of

1. detector capacitance,

- 2. input capacitance of the amplifier, and
- 3. stray capacitances.

Assume an amplifier with a noise voltage  $v_n$  at the input.

Then the signal-to-noise ratio

$$\frac{S}{N} = \frac{V_S}{v_n} \propto \frac{1}{C}$$

• However, S/N does not become infinite as  $C \rightarrow 0$ 

(then front-end operates in current mode)

• The result that  $S/N \propto 1/C$  generally applies to systems that measure signal charge.

Noise vs. Detector Capacitance - Charge-Sensitive Amplifier

In a voltage-sensitive preamplifier

- noise voltage at the output is essentially independent of detector capacitance,
- input signal decreases with increasing input capacitance, so signal-to-noise ratio depends on detector capacitance.

In a charge-sensitive preamplifier, the signal at the amplifier output is independent of detector capacitance (if  $C_i \gg C_d$ ).

What is the noise behavior?

- Noise appearing at the output of the preamplifier is fed back to the input, decreasing the output noise from the open-loop value  $v_{no} = v_{ni}A_v$ .
- The magnitude of the feedback depends on the shunt impedance at the input, i.e. the detector capacitance.

Although specified as an equivalent input noise, the dominant noise sources are typically internal to the amplifier.

Only in a fed-back configuration is some of this noise actually present at the input. In other words, the primary noise signal is not a physical charge (or voltage) at the amplifier input to which the loop responds in the same manner as to a detector signal.

# $\Rightarrow$ *S*/*N* at the amplifier output depends on feedback.

#### Noise in charge-sensitive preamplifiers

Start with an output noise voltage  $v_{no}$ , which is fed back to the input through the capacitive voltage divider  $C_f - C_d$ .



Same result as for voltage amplifier, but here

- the signal is constant and
- the noise grows with increasing C.

As shown previously, the pulse rise time at the amplifier output also increases with total capacitive input load *C*, because of reduced feedback.

In contrast, the rise time of a voltage sensitive amplifier is not affected by the input capacitance, although the equivalent noise charge increases with *C* just as for the charge-sensitive amplifier.

Conclusion

In general

- optimum *S*/*N* is independent of whether the voltage, current, or charge signal is sensed.
- *S*/*N* cannot be *improved* by feedback.

Practical considerations, i.e. type of detector, amplifier technology, can favor one configuration over the other.

# 6. Complex Sensors

Cross-coupled noise



Noise at the input of an amplifier is cross-coupled to its neighbors.

# Principle of Noise Cross-Coupling

Consider a capacitance connecting two amplifier inputs, e.g. amplifiers at opposite electrodes of a detector with capacitance  $C_d$ :



First, assume that amplifier 2 is noiseless.

The noise voltage  $v_{no1}$  causes a current flow  $i_{n1}$  to flow through the feedback capacitance  $C_{f1}$  and the detector capacitance  $C_d$  into the input of amplifier 2.

Note that for a signal originating at the output of amplifier 1, its input impedance  $Z_{i1}$  is high ( $\infty$  for an idealized amplifier), so all of current  $i_{n1}$  flows into amplifier 2.

Amplifier 2 presents a low impedance to the noise current  $\dot{i}_{n1}$ , so its magnitude

$$i_{n1} = \frac{v_{n01}}{X_{C_{f1}} + X_{C_d}} = \frac{v_{n01}}{\frac{1}{\omega C_{f1}} + \frac{1}{\omega C_d}}$$

The voltage at the output of amplifier is the product of the input current times the feedback impedance,

$$v_{no12} = \frac{i_{n1}}{\omega C_{f2}} = \frac{v_{no1}}{\frac{1}{\omega C_{f1}} + \frac{1}{\omega C_d}} \cdot \frac{1}{\omega C_{f2}} = \frac{v_{no1}}{\frac{C_{f2}}{C_{f1}} + \frac{C_{f2}}{C_d}}$$

For identical amplifiers  $C_{f1} = C_{f2}$ . Furthermore,  $C_{f2} \ll C_d$ , so the additional noise from amplifier 1 at the output of amplifier 2 is

$$v_{no12} = v_{no1}$$

This adds in quadrature to the noise of amplifier 2. Since both amplifiers are same,  $v_{no1} = v_{no2}$ , so cross-coupling increases the noise by a factor  $\sqrt{2}$ .

#### Cross-Coupling in Strip Detectors

The backplane capacitance  $C_b$  attenuates the signal transferred through the strip-to-strip capacitance  $C_{ss}$ .

The additional noise introduced into the neighbor channels

$$v_{no1} = v_{no2} \approx \frac{v_{no}}{2} \frac{1}{1 + 2C_b / C_{ss}}$$

For  $C_b = 0$ ,  $v_{no1} = v_{no2} = v_{no}/2$  and the total noise increases by a factor

 $\sqrt{1+0.5^2+0.5^2} = 1.22$ 



For a backplane capacitance  $C_b = C_{ss} / 10$  the noise increases by 16%.

#### In pixel detectors additional paths must be included. This requires realistic data on pixel-pixel capacitances (often needs tests).

# Strip Detector Model for Noise Simulations

Noise coupled from neighbor channels. Analyze signal and noise in center channel.

Includes:

a) Noise contributions from neighbor channels

b) Signal transfer to neighbor channels

- c) Noise from distributed strip resistance
- d) Full SPICE model of preamplifier

Measured Noise of Module:

p-strips on n-bulk, BJT input transistor

Simulation Results: 1460 el (150  $\mu$ A)

1230 el (300 µA)

 $\Rightarrow$  Noise can be predicted with good accuracy.



# **IV. Signal Processing**

- 1. Requirements Two conflicting objectives:
- 1. Improve Signal-to-Noise Ratio S/N

Restrict bandwidth to match measurement time  $\Rightarrow$  Increase pulse width

Typically, the pulse shaper transforms a narrow detector current pulse to

a broader pulse (to reduce electronic noise),

with a gradually rounded maximum at the peaking time  $T_P$  (to facilitate measurement of the peak amplitude)



If the shape of the pulse does not change with signal level, the peak amplitude is also a measure of the energy, so one often speaks of pulse-height measurements or pulse height analysis. The pulse height spectrum is the energy spectrum.



Necessary to find balance between these conflicting requirements. Sometimes minimum noise is crucial, sometimes rate capability is paramount.

Usually, many considerations combined lead to a "non-textbook" compromise.

- *"Optimum shaping" depends on the application!*
- Shapers need not be complicated Every amplifier is a pulse shaper!

# Goal: Improve energy resolution

Procedure: Integrate detector signal current  $\Rightarrow$  Step impulse

 SENSOR PULSE
 INTEGRATOR OUTPUT

  $T_c$   $T_c$ 
 $\rightarrow \mid \leftarrow$   $\rightarrow \mid \leftarrow$ 
 $\prod \leftarrow$   $\prod \leftarrow$ 

Commonly approximated as "step" response (zero rise time).

Long "flat top" allows measurements at times well beyond the collection time  $T_c$ .

 $\Rightarrow$  Allows reduced bandwidth and great flexibility in selecting shaper response.

Optimum for energy measurements, but not for fast timing! "Fast-slow" systems utilize parallel processing chains to optimize both timing and energy resolution (see Timing Measurements in other tutorials).

# 2. Pulse Shapers

Simple Example: CR-RC Shaping



Simple arrangement: Noise performance only 36% worse than optimum filter with same time constants.

- $\Rightarrow$  Useful for estimates, since simple to evaluate
- Key elements:

- lower frequency bound ( $\triangleq$  pulse duration)
- upper frequency bound ( $\triangleq$  rise time)

are common to all shapers.

Pulse Shaping and Signal-to-Noise Ratio

Pulse shaping affects both the

• total noise

and

• peak signal amplitude

at the output of the shaper.

Equivalent Noise Charge

Inject known signal charge into preamp input (either via test input or known energy in detector).

Determine signal-to-noise ratio at shaper output.

Equivalent Noise Charge = Input charge for which S/N = 1

Shapers with Multiple Integrators

Start with simple CR-RC shaper and add additional integrators (n = 1 to n = 2, ..., n = 8).

Change integrator time constants to preserve the peaking time  $\tau_n = \tau_{n=1} / n$ 

Increasing the number of integrators makes the output pulse more symmetrical with a faster return to baseline.

⇒ improved rate capability at the same peaking time



Multiple integrators often do not require additional circuitry. Several gain stages are typically necessary to bring the signal to the level required for a threshold discriminator or analog-to-digital converter. Their bandwidth can be set to provide the desired pulse shaping.

In  $\gamma$ -spectroscopy systems shapers with the equivalent of 8 *RC* integrators are common. Usually, this is achieved with active filters.

# 3. Noise Charge vs. Shaping Time

Assume that differentiator and integrator time constants are equal  $\tau_i = \tau_d \equiv \tau$ .

 $\Rightarrow$  Both cutoff frequencies equal:  $f_U = f_L \equiv f_P = 1/2\pi\tau$ .

Frequency response of individual pulse shaping stages



Combined frequency response



Logarithmic frequency scale  $\Rightarrow$  shape of response independent of  $\tau$ .

Bandwidth  $\Delta f$  decreases with increasing time constant  $\tau$ .

# Comparison with CR-4RC shaper



Both have a 100 ns peaking time.

The peaking frequencies are 1.6 MHz for the CR-RC shaper and 3.2 MHz for the CR-4RC.

The bandwidth, i.e. the difference between the upper and lower half-power frequencies is 3.2 MHz for the CR-RC shaper and 4.3 MHz for the CR-4RC shaper.

The peaking frequency and bandwidth scale with the inverse peaking time.

Result of typical noise measurement vs. shaping time



Noise sources (thermal and shot noise) have a flat ("white") frequency distribution.

Why doesn't the noise decrease monotonically with increasing shaping time (decreasing bandwidth)?

# Analytical Analysis of a Detector Front-End



Detector bias voltage is applied through the resistor  $R_B$ . The bypass capacitor  $C_B$  serves to shunt any external interference coming through the bias supply line to ground. For AC signals this capacitor connects the "far end" of the bias resistor to ground, so that  $R_B$  appears to be in parallel with the detector.

The coupling capacitor  $C_c$  in the amplifier input path blocks the detector bias voltage from the amplifier input (which is why this capacitor is also called a "blocking capacitor").

The series resistor  $R_s$  represents any resistance present in the connection from the detector to the amplifier input. This includes

- the resistance of the detector electrodes
- the resistance of the connecting wires
- any resistors used to protect the amplifier against large voltage transients

#### Equivalent circuit for noise analysis



In this example a voltage-sensitive amplifier is used, so all noise contributions will be calculated in terms of the noise voltage appearing at the amplifier input.

Resistors can be modeled either as voltage or current generators.

- Resistors in parallel with the input act as current sources.
- Resistors in series with the input act as voltage sources.

Steps in the analysis:

- 1. Determine the frequency distribution of the noise voltage presented to the amplifier input from all individual noise sources
- 2. Integrate over the frequency response of a *CR-RC* shaper to determine the total noise output.
- 3. Determine the output signal for a known signal charge and calculate equivalent noise charge (signal charge for S/N = 1)

First, assume a simple *CR*-*RC* shaper with

equal differentiation and integration time constants  $\tau_i = \tau_d = \tau$  ,

which in this special case is equal to the peaking time.

Equivalent Noise Charge

$$\begin{split} Q_n^2 = & \left(\frac{\mathbf{e}^2}{8}\right) \left[ \left(2q_e I_D + \frac{4kT}{R_P} + i_{na}^2\right) \cdot \tau + \left(4kTR_S + e_{na}^2\right) \cdot \frac{C_d^2}{\tau} + 4A_f C_d^2 \right] \\ & \uparrow \qquad \uparrow \qquad \uparrow \qquad \uparrow \\ \mathbf{e} = \exp(1) \qquad \text{current noise} \qquad \text{voltage noise} \qquad 1/f \text{ noise} \\ & \propto \tau \qquad \propto 1/\tau \qquad \text{independent of } \tau \\ & \text{independent of } C_d \qquad \propto C_d^{-2} \qquad \propto C_d^{-2} \end{split}$$

- Current noise is independent of detector capacitance, consistent with the notion of "counting electrons", which is also why it increases with time constant  $\tau$ .
- Voltage noise increases with detector capacitance (reduced signal voltage) and decreases with time constant  $\tau$ .
- 1/f noise is independent of shaping time.

In general, the total noise of a 1/f source depends on the ratio of the upper to lower cutoff frequencies, not on the absolute noise bandwidth. If  $\tau_d$  and  $\tau_i$  are scaled by the same factor, this ratio remains constant.

- Detector leakage current and FET noise decrease with temperature
  - $\Rightarrow$  High resolution Si and Ge detectors for x-rays and gamma rays operate at cryogenic temperatures.

The equivalent noise charge  $Q_n$  assumes a minimum when the current and voltage noise contributions are equal. Typical result:



For a given pulse width CR-RC shaper, the noise minimum obtains for  $\tau_d=\tau_i=\tau$  .

This criterion does not hold for more sophisticated shapers.

# **Time-Variant Shapers**

Time variant shapers change the filter parameters during the processing of individual pulses.

A commonly used time-variant filter is the correlated double-sampler.

- 1. Signals are superimposed on a (slowly) fluctuating baseline
- 2. To remove baseline fluctuations the baseline is sampled prior to the arrival of a signal.
- 3. Next, the signal + baseline is sampled and the previous baseline sample subtracted to obtain the signal

S/N depends on

- 1. time constant of prefilter
- 2. time difference between samples

See "Semiconductor Detector Systems" for a detailed noise analysis. (Chapter 4, pp 160-166)



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# Numerical expression for the noise of a CR-RC shaper (amplifier current noise negligible)

(note that some units are "hidden" in the numerical factors)

$$Q_n^2 = 12 I_B \tau + 6 \cdot 10^5 \frac{\tau}{R_P} + 3.6 \cdot 10^4 e_n^2 \frac{C^2}{\tau}$$
 [rms electrons<sup>2</sup>]

where

- $\tau$  shaping time constant [ns]
- *I<sub>B</sub>* detector bias current + amplifier input current [nA]
- $R_P$  input shunt resistance [k $\Omega$ ]
- $e_n$  equivalent input noise voltage spectral density [nV/ $\sqrt{Hz}$ ]
- C total input capacitance [pF]

$$Q_n = 1 \ e$$
 corresponds to 3.6 eV in Si 2.9 eV in Ge

"Series" and "Parallel" Noise

For sources connected in parallel, currents are additive.

For sources connected in series, voltages are additive.

⇒ In the detector community voltage and current noise are often called "series" and "parallel" noise.

The rest of the world speaks of equivalent noise voltage and current.

Since they are physically meaningful, use of these widely understood terms is preferable.



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The expression for the equivalent noise charge

$$\begin{split} Q_n^2 = & \left(\frac{\mathbf{e}^2}{8}\right) \left[ \left(2q_e I_D + \frac{4kT}{R_p} + i_{na}^2\right) \cdot \tau + \left(4kTR_S + e_{na}^2\right) \cdot \frac{C_d^2}{\tau} + 4A_f C_d^2 \right] \\ & \uparrow \qquad \uparrow \qquad \uparrow \qquad \uparrow \\ \mathbf{e} = \exp(1) \qquad \text{current noise} \qquad \text{voltage noise} \qquad 1/f \text{ noise} \\ & \propto \tau \qquad \propto 1/\tau \qquad \text{independent of } \tau \\ & \text{independent of } C_d \qquad \propto C_d^2 \qquad \propto C_d^2 \end{split}$$

can be put in a more general form that applies to all type of pulse shapers:

$$Q_n^2 = i_n^2 T_s F_i + C^2 e_n^2 \frac{F_v}{T_s} + F_{vf} A_f C^2$$

- The current and voltage terms are combined and represented by  $i_n^2$  and  $e_n^2$ .
- The shaper is characterized by a shape and characteristic time (e.g. the peaking time).
- A specific shaper is described by the "shape factors"  $F_i$ ,  $F_v$ , and  $F_{vf}$ .
- The effect of the shaping time is set by  $T_{\rm s}$ .
- The effective capacitance C exceeds the detector capacitance  $C_d$ , as it must include the preamplifier input capacitance and any other capacitances shunting the input.

### **Detector Noise Summary**

Two basic noise mechanisms: input noise current  $i_n$ input noise voltage  $e_n$ 

Equivalent Noise Charge:  $Q_n^2 = i_n^2 T_s F_i + C^2 e_n^2 \frac{F_v}{T_s}$ 

 $T_{S}$  Characteristic shaping time (*e.g.* peaking time)

- $F_i$  ,  $F_v$  "Shape Factors" that are determined by the shape of the pulse.
- C Total capacitance at the input (detector capacitance + input capacitance of preamplifier + stray capacitance + ... )

Note that  $F_i < F_U$  for higher order shapers.

| Typical values of $F_{i}$ , $F_{\mathcal{U}}$ |                   |                              |
|---|-------------------|------------------------------|
| CR-RC shaper                                  | <i>Fi</i> = 0.924 | $F_{U}$ = 0.924              |
| CR-(RC) <sup>₄</sup> shaper                   | <i>Fi</i> = 0.45  | <i>F<sub>U</sub></i> = 1.02  |
| CR-(RC) <sup>7</sup> shaper                   | <i>Fi</i> = 0.34  | <i>F</i> <sub>U</sub> = 1.27 |
| CAFE chip                                     | <i>Fi</i> = 0.4   | $F_{U}$ = 1.2                |

Shapers can be optimized to reduce current noise contribution relative to the voltage noise (mitigate radiation damage!).

Minimum noise obtains when the current and voltage noise contributions are equal.

#### Current noise

- detector bias current increases with detector size, strongly temperature dependent
- noise from resistors shunting the input increases as resistance is decreased
- input transistor low for FET, higher for BJTs

Voltage noise

 input transistor – noise decreases with increased current



• series resistance, e.g. detector electrode, protection circuits

FETs commonly used as input devices – improved noise performance when cooled ( $T_{opt} \approx 130$  K)

Bipolar transistors are advantageous at short shaping times (<100 ns). When collector current is optimized, bipolar transistor equivalent noise charge is independent of shaping time (see Chapter 6).

# 4. Threshold Discriminator Systems

The simplest form of a digitized readout is a threshold discriminator system, which produces a normalized (digital) output pulse when the input signal exceeds a certain level.

Noise affects not only the resolution of amplitude measurements, but also the determines the minimum detectable signal threshold.

Consider a system that only records the presence of a signal if it exceeds a fixed threshold.



How small a detector pulse can still be detected reliably?

Consider the system at times when no detector signal is present.

Noise will be superimposed on the baseline.

Some noise pulses will exceed the threshold.

This is always true since the amplitude spectrum of Gaussian noise extends to infinity



The threshold must be set

- 1. high enough to suppress noise hits
- 2. low enough to capture the signal



### Combined probability function

Both the amplitude and time distribution are Gaussian.

The rate of noise hits is determined by integrating the combined probability density function in the regime that exceeds the threshold.

This yields

$$f_n = f_{n0} \cdot e^{-Q_T^2/2Q_n^2}$$

where  $Q_T$  and  $Q_n$  are the threshold and noise charge.

Of course, one can just as well use the corresponding voltage levels.

What is the noise rate  $f_{n0}$  at zero threshold ?



For a system with the frequency response A(f) the frequency of zeros

$$f_0^2 = 4 \cdot \frac{\int\limits_0^\infty f^2 A^2(f) df}{\int\limits_0^\infty A^2(f) df}$$

(Rice, Bell System Technical Journal, 23 (1944) 282 and 24 (1945) 46)

Since we are interested in the number of positive excursions exceeding the threshold,  $f_{n0}$  is  $\frac{1}{2}$  the frequency of zero-crossings.

In an ideal band-pass filter with lower and upper cutoff frequencies  $f_1$  and  $f_2$  the noise rate

$$f_0 = 2 \sqrt{\frac{1}{3} \frac{f_2^3 - f_1^3}{f_2 - f_1}}$$

For a *CR-RC* filter with  $\tau_i = \tau_d$  the ratio of cutoff frequencies of the noise bandwidth is

$$\frac{f_2}{f_1} = 4.5$$

so to a good approximation one can neglect the lower cutoff frequency and treat the shaper as a low-pass filter, *i.e.*  $f_1 = 0$  and

$$f_0 \approx \frac{2}{\sqrt{3}} f_2$$

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An ideal bandpass filter has infinitely steep slopes, so the upper cutoff frequency  $f_2$  must be replaced by the noise bandwidth.

The noise bandwidth of an *RC* low-pass filter with time constant  $\tau$  is  $\Delta f_n = \frac{1}{4\tau}$ 

Setting  $f_2 = \Delta f_n$  yields the frequency of zeros

$$f_0 = \frac{1}{2\sqrt{3} \tau}$$

and the frequency of noise hits vs. threshold

$$f_n = f_{n0} \cdot e^{-Q_{th}^2/2Q_n^2} = \frac{f_0}{2} \cdot e^{-Q_{th}^2/2Q_n^2} = \frac{1}{4\sqrt{3} \tau} \cdot e^{-Q_{th}^2/2Q_n^2}$$

Thus, the required threshold-to-noise ratio for a given frequency of noise hits  $f_n$  is

$$\frac{Q_T}{Q_n} = \sqrt{-2\log(4\sqrt{3} f_n \tau)}$$

Note that the product of noise rate and shaping time  $f_n \tau$  determines the required threshold-to-noise ratio, i.e. for a given threshold-to-noise ratio the noise rate is higher at short shaping times

- $\Rightarrow$  The noise rate for a given threshold-to-noise ratio is proportional to bandwidth.
- ⇒ To obtain the same noise rate, a fast system requires a larger threshold-to-noise ratio than a slow system with the same noise level.

Example of noise occupancy (open circles) and efficiency (solid circles) vs. threshold in a practical detector module:



Note that an extended overlap region of high efficiency and low noise occupancy is desired.

The dependence of occupancy on threshold can be used to measure the noise level.

$$\log P_n = \log \left(\frac{\Delta t}{2\sqrt{3} \ \tau}\right) - \frac{1}{2} \left(\frac{Q_T}{Q_n}\right)^2,$$

so the *slope* of log  $P_n$  vs.  $Q_T^2$  yields the noise level.

This analysis is *independent* of the details of the shaper, which affect only the offset.

Measured online during a beam test at KEK in Japan



# 5. Timing Measurements

Pulse height measurements discussed up to now emphasize accurate measurement of signal charge.

- Timing measurements optimize determination of time of occurrence.
- For timing, the figure of merit is not signal-to-noise, but slope-to-noise ratio.

Consider the leading edge of a pulse fed into a threshold discriminator (comparator).

The instantaneous signal level is modulated by noise.

 $\Rightarrow$  time of threshold crossing fluctuates

$$\sigma_{t} = \frac{\sigma_{n}}{\left.\frac{dV}{dt}\right|_{V_{T}}} \approx \frac{t_{r}}{S/N}$$

 $t_r$  = rise time

Typically, the leading edge is not linear, so the optimum trigger level is the point of maximum slope.



### **Pulse Shaping**

Consider a system whose bandwidth is determined by a single *RC* integrator.

The time constant of the RC low-pass filter determines the

- rise time (and hence dV/dt)
- amplifier bandwidth (and hence the noise)

Time dependence: 
$$V_o(t) = V_0(1 - e^{-t/\tau})$$

The rise time is commonly expressed as the interval between the points of 10% and 90% amplitude

$$t_r = 2.2 \ \tau$$

In terms of bandwidth

$$t_r = 2.2 \ \tau = \frac{2.2}{2\pi \ f_u} = \frac{0.35}{f_u}$$

Example: An oscilloscope with 100 MHz bandwidth has 3.5 ns rise time.

For a cascade of amplifiers:  $t_r \approx \sqrt{t_{r1}^2 + t_{r2}^2 + \ldots + t_{rn}^2}$ 

#### Choice of Rise Time in a Timing System

Assume a detector pulse with peak amplitude  $V_0$  and a rise time  $t_c$  passing through an amplifier chain with a rise time  $t_{ra}$ .

1. Amplifier rise time  $\gg$  Signal rise time:

Noise 
$$\propto \sqrt{f_u} \propto \sqrt{\frac{1}{t_{ra}}}$$
  
 $\frac{dV}{dt} \propto \frac{1}{t_{ra}} \propto f_u$ 

increase in bandwidth  $\Rightarrow$  improvement in dV/dt outweighs increase in noise.

2. Amplifier rise time  $\ll$  Signal rise time

increase in noise without increase in dV/dt

Optimum: The amplifier rise time should be chosen to match the signal rise time.

Differentiation time constant: choose greater than rise time constant

( $\tau_{diff} = 10\tau_{int}$  incurs 20% loss in pulse height)

### Time Walk

For a fixed trigger level the time of threshold crossing depends on pulse amplitude.

- $\Rightarrow$  Accuracy of timing measurement limited by
  - jitter (due to noise)
  - time walk (due to amplitude variations)



If the rise time is known, "time walk" can be compensated in software event-by-event by measuring the pulse height and correcting the time measurement.

This technique fails if both amplitude and rise time vary, as is common.

In hardware, time walk can be reduced by setting the threshold to the lowest practical level, or by using amplitude compensation circuitry, e.g. constant fraction triggering.

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### Lowest Practical Threshold

Single *RC* integrator has maximum slope at t = 0:  $\frac{d}{dt}(1 - e^{-t/\tau}) = \frac{1}{\tau} e^{-t/\tau}$ 

However, the rise time of practically all fast timing systems is determined by multiple time constants.

For small *t* the slope at the output of a single RC integrator is linear, so initially the pulse can be approximated by a ramp  $\alpha t$ .

Response of the following integrator

$$V_i = \alpha \ t \quad \rightarrow \quad V_o = \alpha (t - \tau) - \alpha \ \tau \ e^{-t/\tau}$$

 $\Rightarrow \text{ The output is delayed by } \tau \\ \text{and curvature is introduced at small } t.$ 

Output attains 90% of input slope after  $t = 2.3\tau$ .

Delay for *n* integrators =  $n\tau$ 



NORMALIZED TIME  $t / \tau$ 

Additional *RC* integrators introduce more curvature at the beginning of the pulse.



Increased curvature at beginning of pulse limits the minimum threshold for good timing.

 $\Rightarrow$  One dominant time constant best for timing measurements

Unlike amplitude measurements, where multiple integrators are desirable to improve pulse symmetry and count rate performance.

#### Fast Timing: Comparison between theory and experiment



For more details on fast timing with semiconductor detectors, see

H. Spieler, IEEE Trans. Nucl. Sci. NS-29/3 (1982) 1142.

# 6. Digitization of Pulse Height – Analog to Digital Conversion

For data storage and subsequent analysis the analog signal at the shaper output must be digitized.

Important parameters for ADCs used in detector systems:

1. Resolution

The "granularity" of the digitized output

- 2. Differential Non-Linearity How uniform are the digitization increments?
- 3. Integral Non-Linearity Is the digital output proportional to the analog input?
- 4. Conversion Time

How much time is required to convert an analog signal to a digital output?

5. Count-Rate Performance

How guickly can a new conversion commence after completion of a prior one without introducing deleterious artifacts?

6. Stability

Do the conversion parameters change with time?

Instrumentation ADCs used in industrial data acquisition and control systems share most of these requirements. However, detector systems place greater emphasis on differential nonlinearity and count-rate performance. The latter is important, as detector signals often occur randomly, in contrast to measurement systems where signals are sampled at regular intervals.

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## 6.1 Resolution

Digitization incurs approximation, as a continuous signal distribution is transformed into a discrete set of values. To reduce the additional errors (noise) introduced by digitization, the discrete digital steps must correspond to a sufficiently small analog increment.

Simplistic assumption:

Resolution is defined by the number of output bits, e.g. 13 bits  $\rightarrow \frac{\Delta V}{V} = \frac{1}{8192} = 1.2 \cdot 10^{-4}$ 

True Measure: Channel Profile

Plot probability vs. pulse amplitude that a pulse height corresponding to a specific output bin is actually converted to that address.

Ideal ADC:

Measurement accuracy:

- If all counts of a peak fall in one bin, the resolution is  $\Delta V$ .
- If the counts are distributed over several bins, peak fitting can yield a resolution of  $10^{-1} 10^{-2} \Delta V$ , *if the distribution is known and reproducible* (not necessarily a valid assumption for an ADC).



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In reality, the channel profile is not rectangular as sketched above.

Electronic noise in the threshold discrimination process that determines the channel boundaries "smears" the transition from one bin to the next.

Measured channel profile (13 bit ADC)

The profiles of adjacent channels overlap.



Channel profile can be checked quickly by applying the output of a precision pulser to the ADC.

If the pulser output has very low noise, i.e. the amplitude jitter is much smaller than the voltage increment corresponding to one ADC channel or bin, all pulses will be converted to a single channel, with only a small fraction appearing in the neighbor channels.

Example of an ADC whose digital resolution is greater than its analog resolution:



Here the 2K range provides maximum resolution – higher ranges superfluous.

How much ADC Resolution is Required?



Fitting can determine centroid position to fraction of bin width even with coarse digitization, **if only a single peak is present and the line shape is known**.

### 6.2 Differential Non-Linearity

Differential non-linearity is a measure of the non-uniformity of channel profiles over the range of the ADC.

Depending on the nature of the distribution, either a peak or an rms specification may be appropriate.

$$DNL = \max \left\{ \frac{\Delta V(i)}{\langle \Delta V \rangle} - 1 \right\}$$
 or  $DNL = r.m.s. \left\{ \frac{\Delta V(i)}{\langle \Delta V \rangle} - 1 \right\}$ 

where  $\langle \Delta V \rangle$  is the average channel width and

 $\Delta V(i)$  is the width of an individual channel.

Differential non-linearity of  $< \pm 1\%$  max. is typical in nuclear science ADCs,

but state-of-the-art ADCs can achieve 10<sup>-3</sup> rms,

i.e. the variation is comparable to the statistical fluctuation for 10<sup>6</sup> random counts.



An ideal ADC would show an equal number of counts in each bin.

The spectrum to the left shows a random pattern, but

note the multiple periodicities visible in the right hand spectrum.

- **Note:** Instrumentation ADCs are often specified with an accuracy of  $\pm 0.5$  LSB (least significant bit) or more, so
  - 1. the differential non-linearity may be 50% or more,
  - 2. the response may be non-monotonic
    - $\Rightarrow$  output may decrease when input rises.

### 6.3 Integral Non-Linearity

Integral non-linearity measures the deviation from proportionality of the measured amplitude to the input signal level.



The dots are measured values and the line is a fit to the data.

This plot is not very useful if the deviations from linearity are small.

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Plotting the deviations of the measured points from the fit yields a more useful result.

Integral non-linearity measured with a 400 ns wide input pulse

The linearity of an ADC can depend on the input pulse shape and duration, due to bandwidth limitations in the circuitry.

Increasing the pulse width to 3  $\mu$ s improved the linearity significantly:



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## 6.4 Conversion Time

During the digitization of a signal a subsequent signal is lost ("dead time").

Dead Time =

| signal acquisition time  | $\rightarrow$ | time-to-peak + const.   |
|--------------------------|---------------|---|
| + conversion time        | $\rightarrow$ | can depend on pulse height  |
| + readout time to memory | $\rightarrow$ | depends on speed of data transmission and<br>buffer memory access |

Dead time affects measurements of yields or reaction cross-sections. Unless the event rate << 1/(dead time), it is necessary to measure the dead time, e.g. with a reference pulser fed simultaneously into the spectrum.

The total number of reference pulses issued during the measurement is determined by a scaler and compared with the number of pulses recorded in the spectrum.

Does a pulse-height dependent dead time mean that the correction is a function of pulse height?

Usually not. If events in different part of the spectrum are not correlated in time, i.e. random, they are all subject to the same average dead time (although this average will depend on the spectral distribution).

• Caution with correlated events!

Example: Decay chains, where lifetime is < dead time. The daughter decay will be lost systematically.

## 6.5 Count Rate Effects

Problems are usually due to internal baseline shifts with event rate or undershoots following a pulse.

If signals occur at constant intervals, the effect of an undershoot will always be the same.

However, in a random sequence of pulses, the effect will vary from pulse to pulse.

⇒ spectral broadening

Baseline shifts tend to manifest themselves as a systematic shift in centroid position with event rate.

Centroid shifts for two 13 bit ADCs vs. random rate: Not all ADCs work as expected. Not all ADCs work as expected. (9)

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# 6.6 Stability

Stability vs. temperature is usually adequate with modern electronics in a laboratory environment.

- Note that temperature changes within a module are typically much smaller than ambient.
  - However: Highly precise or long-term measurements require spectrum stabilization to compensate for changes in gain and baseline of the overall system.
  - Technique: Using precision pulsers place a reference peak at both the low and high end of the spectrum.

 $(Pk. Pos. 2) - (Pk. Pos. 1) \rightarrow Gain, ...$ 

then

```
(Pk. Pos. 1) or (Pk. Pos. 2) \rightarrow Offset
```

Traditional Implementation: Hardware, spectrum stabilizer module

Today, it is more convenient to determine the corrections in software.

These can be applied to calibration corrections or used to derive an electrical signal that is applied to the hardware (simplest and best in the ADC).

# 7. Digital Signal Processing

Sample detector signal with fast digitizer to reconstruct pulse:

Then use digital signal processor to perform mathematical operations for desired pulse shaping.

**Block Diagram** 



0.5 -

0.4

0.3

0.2

0.1

0.0

0

10

TIME (ns)

SIGNAL CURRENT (µA)

DSP allows great flexibility in implementing filtering functions

However: increased circuit complexity

increased demands on ADC, compared to traditional shaping.



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Important to choose sample interval sufficiently small to capture pulse structure.

Sampling interval of 4 ns misses initial peak.

With too low a sampling rate high frequency components will be "aliased" to lower frequencies:

Applies to any form of sampling (time waveform, image, ...)

Nyquist condition:

Sampling frequency > 2x highest signal frequency



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- Dynamic range requirements for ADC may be more severe than in analog filtered system (depending on pulse shape and pre-filter).
- Digitization introduces additional noise ("quantization noise")

If one bit corresponds to an amplitude interval  $\Delta$ , the quantization noise

$$\sigma_v^2 = \int_{-\Delta/2}^{\Delta/2} \frac{v^2}{\Delta} \, dv = \frac{\Delta^2}{12} \, .$$

(differential non-linearity introduces quasi-random noise)

- Electronics preceding ADC and front-end of ADC must exhibit same precision as analog system, i.e. baseline and other pulse-to-pulse amplitude fluctuations less than order  $Q_n/10$ , i.e. typically 10<sup>-4</sup> in high-resolution systems. For 10 V FS at the ADC input this corresponds to < 1 mV.
- $\Rightarrow$  ADC must provide high performance at short conversion times. Today this is technically feasible for some applications, e.g. detectors with moderate to long collection times ( $\gamma$  and x-ray detectors).

### **Digital Filtering**

Filtering is performed by convolution: 
$$S_o(n) = \sum_{k=0}^{N-1} W(k) \cdot S_i(n-k)$$

W(k) is a set of coefficients that describes the weighting function yielding the desired pulse shape.

A filter performing this function is called a Finite Impulse Response (FIR) filter.

This is analogous to filtering in the frequency domain:

In the frequency domain the result of filtering is determined by multiplying the responses of the individual stages:

$$G(f) = G_1(f) \cdot G_2(f)$$

where  $G_1(f)$  and  $G_1(f)$  are complex numbers.

The theory of Fourier transforms states that the equivalent result in the time domain is formed by convolution of the individual time responses:

$$g(t) = g_1(t) * g_2(t) \equiv \int_{-\infty}^{+\infty} g_1(\tau) \cdot g_2(t-\tau) d\tau$$

analogously to the discrete sum shown above.

ADCs often have excessive noise.

Increasing gain to increase the signal level into the ADC will reduce the ADC noise contribution, but reduce the dynamic range.

For a preamplifier input noise  $\upsilon_{\scriptscriptstyle n1}$  fed to the ADC input noise  $\upsilon_{\scriptscriptstyle n2}$  with a gain G , the overall noise

$$v_n = \frac{\sqrt{(v_{n1}G)^2 + v_{n2}^2}}{G} = \sqrt{v_{n1}^2 + \left(\frac{v_{n2}}{G}\right)^2}$$

The ratio of the overall noise to the ADC noise

$$\frac{v_n}{v_{n2}} = \sqrt{\left(\frac{v_{n1}}{v_{n2}}\right)^2 + \left(\frac{1}{G}\right)^2}$$

The resulting dynamic range given by the ratio of the maximum ADC input signal level to the combined noise is

$$\frac{V_{i0}^{max}}{v_{n}} = \frac{V_{i0}^{max} / G}{\sqrt{v_{n1}^{2} + (v_{n2} / G)^{2}}} = \frac{V_{i0}^{max}}{v_{n2}} \frac{1}{\sqrt{\left(\frac{v_{n1}}{v_{n2}}G\right)^{2} + 1}}$$

The second factor is the reduction of dynamic range.

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Change in dynamic range and noise vs. pre-ADC gain for various ratios of the pre-circuit noise  $v_{n1}$  to the ADC noise  $v_{n2}$ 


Given a sufficient sampling rate, digital signal processing will provide the same results as an analog system.

The equivalent noise charge expression yielding the results of current noise, voltage, and 1/f voltage noise

$$Q_{n}^{2} = i_{n}^{2} F_{i} T_{S} + e_{n}^{2} F_{v} \frac{C^{2}}{T_{S}} + F_{vf} A_{f} C^{2}$$

applies to both analog and digital signal processing, provided the additional noise contributions in digital processing are negligible.

Potential Problems as noted above are insufficient sampling rate and excessive ADC noise, in addition to digital crosstalk.

Digital vs. Analog Processing

Benefits of digital signal processing:

- Flexibility in implementing filter functions
- Filters possible that are impractical in hardware
- Simple to change filter parameters
- Tail cancellation and pile-up rejection easily incorporated
- Adaptive filtering can be used to compensate for pulse shape variations.

Where is digital signal processing appropriate?

• Systems highly optimized for Resolution

High counting rates

• Variable detector pulse shapes

Where is analog signal processing best (most efficient)?

- Fast shaping
- Systems not sensitive to pulse shape (fixed shaper constants)
- High density systems that require small circuit area or low power

## Both types of systems require careful analog design.

Progress in fast ADCs (precision, reduced power) will expand range of DSP applications.

VI. Why Things Don't Work - Why S/N Theory Often Seems to be Irrelevant

There are many reasons why things don't work ...

1. Idiocy

- 2. Incompetence
- 3. Meetings (where decisions are made, but many participants are incompetent)

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## However, you might also encounter some technical problems:

Throughout the previous lectures it was assumed that the only sources of noise were

- random
- known
- in the detector, preamplifier, or associated components

In practice, the detector system will pick up spurious signals that are

- not random,
- but not correlated with the signal,

so with reference to the signal they are quasi-random.

- $\Rightarrow$  Baseline fluctuations superimposed on the desired signal
- $\Rightarrow$  Increased detection threshold, degradation of resolution

Important to distinguish between

- pickup of spurious signals, either from local or remote sources (clocks, digital circuitry, readout lines),
- self-oscillation (circuit provides feedback path that causes sustained oscillation due to a portion of the output reaching the input)

External Pickup is often the cause, but many problems are due to poor work practices or inappropriate equipment

# 1. Termination of Cables

Signals are transmitted from one unit to another through transmission lines, often coaxial cables or ribbon cables.

When transmission lines are not terminated with their characteristic impedance, the signals are reflected.



# Example:

1 K in parallel with 30 pF is a typical input impedance for a shaping amplifier.

If feeding a counter, each signal pulse will be registered the multiple times, depending on the threshold setting. When the cable is properly terminated, reflections disappear.



Two methods of terminating cables:



In this configuration the original pulse is reflected at the receiving end, but the reflection is absorbed at the sending end, so it doesn't reappear at the receiver.

The series resistor feeding the transmission line forms a voltage divider that attenuates the pulse amplitude by a factor of 2.

However, since the high impedance at the end of the cable causes a reflected pulse with the same amplitude, the pulse amplitude is doubled, so it is the same as the original.

Terminations are never perfect, especially at high frequencies (>10 ... 100 MHz), so in critical applications one can use both series and parallel termination. However, this does incur a 50% reduction in pulse amplitude.

In the  $>\mu$ s regime, amplifier inputs are usually high impedance, whereas timing amplifiers tend to be internally terminated (check!).

Noisy Detector Bias Supplies

The detector is the most sensitive node in the system.

Any disturbance  $\Delta V$  on the detector bias line will induce charge in the input circuit.

$$\Delta Q = C_d \Delta V$$

 $\Delta V =$  10 µV and 10 pF detector capacitance yield  $\Delta Q \approx$  0.1 fC – about 600 el or 2 keV (Si).

Especially when the detector bias is low (<100V), it is tempting to use a general laboratory power supply.



Frequently, power supplies are very noisy – especially old units.

The *RC* circuits in the bias line provide some filtering, but usually not enough for a typical power supply

Beware of switching power supplies. Well-designed switching regulators can be very clean, but most switchers are very noisy.

Spikes on the output can be quite large, but short, so that the rms noise specification may appear adequate, although it is not.

## $\Rightarrow$ Use very low noise power supplies.

# Common Types of Interference

# 1. Light Pick-Up

Critical systems:

- Photomultiplier tubes
- Semiconductor detectors (all semiconductor detectors are photodiodes)

#### Sources

- Room lighting (Light Leaks)
- Vacuum gauges

Interference is correlated with the power line frequency (60 Hz in U.S., 50 Hz in Europe, Japan)

Pickup from incandescent lamps has twice the line frequency (light intensity  $\propto$  voltage squared)

**Diagnostics:** 

- a) Inspect signal output with oscilloscope set to trigger mode "line". Look for stationary structure on baseline. Analog oscilloscope better than digital.
- b) Switch off light
- c) Cover system with black cloth (preferably felt, or very densely woven – check if you can see through)

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## 2. Microphonics

If the electrode at potential  $V_{\!_B}$  vibrates with respect to the enclosure, the stray capacitance C is modulated by  $\Delta C(t)$ , inducing a charge

$$\Delta Q(t) = V_b \Delta C(t)$$

in the detector signal circuit.

Typically, vibrations are excited by motors (vacuum pumps, blowers), so the interference tends to be correlated with the line frequency.

Check with

- a) oscilloscope on line trigger
- b) hand to feel vibrations

This type of pickup only occurs between conductors at different potentials, so it can be reduced by shielding the relevant electrode.

a) intermediate shield at electrode potential

b) in coaxial detectors, keep outer electrode at 0 V.



## 3. RF Pickup

All detector electronics are sensitive to RF signals.

The critical frequency range depends on the shaping time. The gain of the system peaks at

 $f \approx \frac{1}{2\pi\tau}$ 

and high-gain systems will be sensitive over a wide range of frequencies around the peaking frequency.

Typical sources:

- Radio and TV stations
   AM broadcast stations: 0.5 1.7 MHz
   FM broadcast stations: ~ 100 MHz
   TV stations: 50 800 MHz
- Induction furnaces (13.6, 27, 40 MHz)
- Accelerators

⇒ Pulses

Radar (GHz)

data readout)

 $\Rightarrow$  Sine Waves

(or recurring damped oscillations)

Internal clock pulses (e.g. digital control,

Computers (10's to 100's MHz)

Video Displays (10 – 100 kHz)

Pulsed UHF or microwave emissions can affect low-frequency circuitry by driving it beyond linearity (the bandwidth of the preamplifier can be much greater than of the subsequent shaper).

#### **Diagnostic Techniques**

a) Inspect analog output on an oscilloscope.

Check with different trigger levels and deflection times and look for periodic structure on the baseline.

Pickup levels as low as 10% of the noise level can be serious, so careful adjustment of the trigger and judicious squinting of the eye is necessary to see periodic structure superimposed on the random noise.

Again, an "old fashioned" analog oscilloscope is best.

b) Inspect output with a spectrum analyzer

This is a very sensitive technique.

Indeed, for some it may be too sensitive, as it tends to show signals that are so small that they are irrelevant.

Ascertain quantitatively what levels of interfering signals vs. frequency are important.

## **Remedial Techniques**



Conducting shield attenuates an incident electromagnetic wave because of

• Reflection of the incident wave  $E_{0r} = E_0 \left( 1 - \frac{Z_{shield}}{Z_0} \right)$  where  $Z_0 = \sqrt{\frac{\mu}{\varepsilon}} = 377 \ \Omega$  is the impedance of free space.

The impedance of the conductor is very low, so most of the incident wave is reflected.

This mechanism is only operative in the far field (distances >  $\lambda$  from source).

Attenuation of the absorbed wave – the effect of shield thickness

The absorbed wave gives rise to a local current, whose field counteracts the primary excitation.

The net current decreases exponentially as the wave penetrates deeper into the medium

$$i(x) = i_0 e^{-x/\delta}$$

where  $i_0$  is the current at the surface of the conductor and

$$\delta = \frac{1}{2 \cdot 10^{-4}} \left[ \sqrt{\mathrm{cm} \cdot \mathrm{s}^{-1}} \right] \sqrt{\frac{\rho}{\mu_r f}}$$

is the penetration depth or "skin depth".

 $\mu_r$  and  $\rho$  are the permeability and resistivity of the conductor and *f* is the frequency of the incident wave.

In aluminum,  $\rho$  = 2.8  $\mu\Omega$  <sup>·</sup> cm and  $\mu_r$  = 1, so at f = 1 MHz

the skin depth  $\delta$  = 84 µm ≈100 µm.

The skin depth decreases with the square root of

- increasing frequency
- decreasing resistivity (increasing conductivity)

If the shield is sufficiently thick, the skin effect isolates the inner surface of a shielding enclosure from the outer surface.

However, this isolation only obtains if no openings in the shield allow the current to flow from the outside to the inside.

External fields can penetrate if openings >  $\lambda$  /1000 (diameter of holes, length of slots).

To maintain the integrity of the shield,

 covers must fit tightly with good conductivity at the seams (beware of anodized aluminum!),



- all input and output lines (signal and DC supplies) must have good shield connections,
- shield coverage of coax or other cables >90%, and
- connectors must maintain the integrity of the shield connection.
  - ⇒ Enclosure must be "water tight" to effectively suppress pickup at high frequencies (> order 10 MHz).



# Example: RF-tight shielding of multi-channel sub-ns amplifier

## b) "Field Line Pinning"

 $C_2$ 

Full shielding is not always practical, nor is it always necessary.

Rather than preventing interference currents from entering the detector system, it is often more practical to reduce the coupling of the interference to the critical nodes.

Consider a conductor carrying an undesired signal current, with a corresponding signal voltage. Capacitive coupling will transfer interference to another circuit node If an intermediate conductor is introduced with a large capacitance to the interference source and to ground compared to the critical node, it will "capture" the field lines and effectively "shield" the critical node.





#### c) "Self-Shielding" Structures



The capacitance between electrode sets 2 and 3 is  $\mathcal{E}_r$  times larger than in sets 1 to 2.

Example: Si,  $\varepsilon_r = 11.9 \Rightarrow 92.2\%$  of the field lines originating from electrode set 2 terminate on set 3, i.e. are confined to the Si bulk 7.8% terminate on set 1.

For comparison, with  $\varepsilon_r = 1,50\%$  of the field lines originating from electrode set 2 terminate on set 1.

⇒ High dielectric constant reduces coupling of electrode sets 2 and 3 to external sources.

If the interference source is represented by electrode set 1 and sets 2 and 3 represent a detector

⇒ Si detector is 6.5 times less sensitive to capacitive pickup then a detector with  $\varepsilon_r = 1$  (e.g. a gas chamber with the same geometry)

## d) "Self-Shielding" Cables

In mixed analog-digital systems, interfering signals may radiate from cables, especially digital transmission lines.

By utilizing broadside-coupled differential lines with a thin intermediate dielectric, the field is confined to the region between the conductors. The extent of the fringing field beyond the conductor edge is about equal to the thickness of the dielectric.

Example:



Power connections are made substantially wider (1 - 5 mm), forming a low impedance transmission line with high distributed capacitance.

The geometry shown above is for short runs in the inner region of a tracker, where reduction of material is crucial. Dimensions can be scaled proportionally to achieve lower resistance and signal dispersion in longer cable runs at larger radii.

#### 4. Inductive Coupling

A varying B field induces voltages in circuit loops.



Clearly, the area A enclosed by any loops should be minimized.

Accomplished by routing signal line and return as a closely spaced pair.

Better yet is a twisted pair, where the voltages induced in successive twists cancel.

Problems occur when alternating detector electrodes are read out at opposite ends – often done because of mechanical constraints.

## 5. Shared Current Paths – Grounding and the power of Myth

Although capacitive or inductive coupling cannot be ignored, the most prevalent mechanism of undesired signal transfer is the existence of shared signal paths.

#### Mechanism:

A large alternating current  $I_1$  is coupled into the common ground bus.

Although the circuit associated with generator  $V_1$  has a dedicated current return, the current seeks the past of least resistance, which is the massive ground bus.

The lower circuit is a sensitive signal transmission path. Following the common lore, it is connected to ground at both the source and receiver.

The large current flowing through the ground bus causes a voltage drop  $\Delta V$ , which is superimposed on the low-level signal loop

associated with  $V_2$  and appears as an additional signal component.

• Cross-coupling has *nothing to do with grounding per se*, but is due to the common return path. However, the common ground caused the problem by establishing the shared path.

In systems that respond to transients (i.e. time-varying signals) rather than DC signals, secondary loops can be closed by capacitance. A DC path is not necessary.





The loops in this figure are the same as shown before, but the loops are closed by the capacitances  $C_{s1}$  and  $C_{s2}$ .

Frequently, these capacitances are not formed explicitly by capacitors, but are the stray capacitance formed by a power supply to ground, a detector to its support structure (as represented by  $C_{s2}$ ), etc.

For AC signals the inductance of the common current path can increase the impedance substantially beyond the DC resistance, especially at high frequencies.

This mode of interference occurs whenever spurious voltages are introduced into the signal path and superimpose on the desired signal.

#### Interference does not cross-couple by voltage alone, but also via current injection.

Current spikes originating in logic circuitry, for example, propagate through the bussing system as on a transmission line.

Individual connection points will absorb some fraction of the current signal, depending on the relative impedance of the node.



**Remedial Techniques** 

#### 1. Reduce impedance of the common path

 $\Rightarrow$  Copper Braid Syndrome

Colloquially called "improving ground".

(sometimes fortuitously introduces an out-of-phase component of the original interference, leading to cancellation)

#### Rather haphazard, poorly controlled $\Rightarrow$ continual surprises

## 2. Avoid Grounds

Circuits rely on current return paths, not a ground connection!



In transferring from stage to stage the signal current flows through local return loops.

- 1. At the input the detector signal is applied between the gate and source of Q1
- 2. At the output of Q1 the signal is developed across the load resistor in the drain of Q1 and applied between the gate and source of Q2.
- 3. The output of Q2 is developed across the load resistor in its drain and applied across the gate and source resistor and load.

Note that – disregarding the input voltage divider that biases Q1

- varying either +V or -V does not affect the local signals.

# Breaking parasitic signal paths

Example:

The configuration at the left has a loop that includes the most sensitive part of the system – the detector and preamplifier input.

By introducing insulated feedthroughs, the input loop is broken.



Note that a new loop is shown, introduced by the common detector bias supply. This loop is restricted to the output circuit of the preamplifier, where the signal has been amplified, so it is less sensitive to interference.

- Note that the problem is not caused by loops *per se*, i.e. enclosed areas, but by the multiple connections that provide entry paths for interference.
- Although not shown in the schematic illustrations above, both the "detector box" (e.g. a scattering chamber) and the main amplifiers (e.g. in a NIM bin or VME crate) are connected to potential interference sources, so currents can flow through parts of the input signal path.

Breaking shared signal paths, cont'd

#### **1. Differential Receivers**

Besides providing common mode noise rejection, differential receivers also allow "ground free" connections.

Ideal configuration using differential drivers and receivers:



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Technique also usable with single-ended drivers:



At the receiver input high-value resistors to ground provide potential referencing between the transmitter and receiver to avoid exceeding the common mode range of the receiver.

The transmission line is terminated by the shunt resistor (typ. 100  $\Omega$ )

## 2. Insert high impedances

Ferrite sleeves block common mode currents.

Signal current in coax line flows on

- outer surface of inner conductor
- inner surface of shield.





Net field at *outer surface* of shield is zero.  $\Rightarrow$ 

Ferrite sleeve does not affect signal transmission.

Common mode currents in the coax line (current flow in same direction on inner and outer conductor)

#### or

current components flowing only on the outside surface of the shield ("ground loops") will couple to the ferrite and be suppressed.

Ferrite material must be selected to present high impedance at relevant frequencies.

Technique can also be applied to twisted-pair ribbon cables.

#### Series resistors isolate parasitic ground connections.

Example: Detector bias voltage connection

Isolation resistors can also be mounted in an external box that is looped into the bias cable. Either use an insulated box or be sure to isolate the shells of the input and output connectors from another.

A simple check for noise introduced through the detector bias connection is to use a battery.



"Ground loops" are often formed by the third wire in the AC power connection. Avoid voltage differences in the "ground" connection by connecting all power cords associated with low-level circuitry into the same outlet strip.

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## 3. Direct the current flow away from sensitive nodes

A timing discriminator was built on a PC board and mounted in a NIM module with multiple channels.

All inputs and outputs were mounted on the front panel. The outputs drove about 20 mA into 50  $\Omega$  cables.

Whenever an output fired, the unit broke into oscillation.



A portion of the output current flowed through the input ground connection. The voltage drop  $\Delta V$  was sufficient to fire the comparator.

Breaking the loop by insulating the output connector from the front panel fixed the problem.





Current paths can be controlled by patterning the ground plane.



#### Ground returns are also critical at the circuit level.

Currents in output drivers:

In addition to the signal currents  $I_{in}$  and  $I_{out}$ , the drain current is also changing with the signal and must return to the source. Since the return through the power supply can be remote and circuitous, a well-defined AC return path is provided by the bypass capacitor.

Since the input and output signal voltages are usually referenced to the negative supply rail, circuits commonly configure it as a common large area bus, the "ground", and all nodes are referenced to it.





Since the "ground" is a large area conducting surface

- often a chassis or a ground plane -

with a "low" impedance, it is considered to be an equipotential surface.

## The assumption that "ground" is an equipotential surface is not always justified.

For high frequency signals ( > 1 MHz) it is PRACTICALLY NEVER justified.

At high frequencies current flows only in a thin surface layer ("skin effect").

The skin depth in aluminum is ~100  $\mu$ m at 1 MHz.

A pulse with a 3 ns rise-time will have substantial Fourier components beyond 100 MHz, where the skin depth is 10  $\mu$ m.

 $\Rightarrow$  Even large area conductors can have substantial resistance!

Example: A strip of aluminum, 1 cm wide and 5 cm long has a resistance of ~20 m $\Omega$  at 100 MHz (single surface, typical Al alloy)

100 mA  $\Rightarrow$  2 mV voltage drop,

which can be much larger than the signal.

The resistance is determined by the ratio of length to width, i.e. a strip 1 mm wide and 5 mm long will show the same behavior.

Inductance can increase impedances much beyond this value!

Consider a current loop closed by two connections to a ground plane.

Current distribution around the two connection points

The dashed lines indicate equipotential contours.



Assume a total drop of 100 mV.

The resulting potential distribution is shown below.


Mounting a circuit block (an IC, for example) with ground and bypass connections as shown below introduces a 50 mV voltage drop in the "ground" path. Direct connection of the bypass capacitor between the V+ and GND pads avoids pickup of the voltage drop on the ground plane.





#### "Ground" Connections in Multi-Stage Circuits

IC combining a preamplifier, gain stages and an output driver:



The output current is typically orders of magnitude greater than the input current (due to amplifier gain, load impedance).

Combining all ground returns in one bond pad creates a shared impedance (inductance of bond wire).

# This also illustrates the use of a popular technique – the "star" ground

- and its pitfalls.

Separating the "ground" connections by current return paths routes currents away from the common impedance and constrains the extent of the output loop, which tends to carry the highest current.



#### The Folded Cascode

The folded cascode is frequently used in preamplifiers optimized for low power.

Standard cascode with representative transistor sizes:

The cascode combines two transistors to obtain

- the high transconductance and low noise of a wide transistor
- the high output resistance (increased by local feedback) and small output capacitance of a narrow transistor
- reduced capacitance between output and input



Since the input transistor determines the noise level, its current requirement tends to dominate.

In a conventional cascode the current required for the input transistor must flow through the whole chain.

The folded cascode allows the (second) cascode transistor to operate at a lower current and, as a result, higher output resistance.

PMOS transistors tend to have lower "1/f" noise than NMOS devices, so this adaptation is often used:



The problem with this configuration is that the supply  $V_1$  becomes part of the input signal path. Unless the  $V_1$  supply bus is very carefully configured and kept free of other signals, interference will be coupled into the input.

Consider the circuit connected to a strip detector:



Unless the connection points of the bypass capacitors from the FET source and the detector backplane are chosen carefully, interference will be introduced into the input signal loop.

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It is much better to "ground" the FET source to a local signal reference and use a negative second supply.



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Connected to a strip detector (and redrawn slightly), this configuration provides a direct input return loop.



For some (mythical?) reason positive supplies are more popular. Proper connection of the detector can still provide a direct input path.



In most implementations supply lines are more susceptible to pickup, so the  $+V_1$  line must be properly filtered to prevent current injection.

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### **Choice of Capacitors**

Capacitors are often in signal return paths. As bypass capacitors they must buffer large current pulses.

All capacitors form a series resonant circuit. Above the resonance frequency they act inductive. The loss resistance (equivalent series resistance, ESR) limits the impedance at resonance.



Y5V has large voltage dependence, typ. ~20% of nominal capacitance at rated voltage. X7R better.

### Other Considerations

## 1. Choice of Shaper

Although a bipolar shaper has slightly inferior noise performance than a unipolar shaper, it may provide better results in the presence of significant low-frequency noise.

Minimum Noise



 $10^{0}$ 

10<sup>-1</sup>

CR-RC

In the frequency domain the additional CR-stage (low-pass filter) provides substantial attenuation of low-frequency interference.

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## 2. Local Referencing

Noise currents on the cooling or support structures can couple to the detector input node.

⇒ Keep stave and module at same high-frequency potential

Keep mounting capacitance small,

Control spurious signals on mount

Easier said than done.

Just one example for a common challenge.

### Very important!

Often the rational for "grounding", but think of the physical mechanisms before blindly following recipes.



# Summary

• Detectors involve a wide range of interacting functions – often conflicting.

Requires understanding the physics of the

experiment, detector, and readout,

rather then merely following recipes.

- Physics requirements must be translated to engineering parameters.
- Many details interact, even in conceptually simple designs.

View in different aspects, e.g. analysis in time and frequency domain

• Single-channel recipes tend to be incomplete

- Overall interactions must be considered.

- Don't blindly accept the results of simulations. Do cross checks!
- Novel detectors often build on a range of different concepts. Appropriate compromises often enable systems that were called impractical.

The broad range of physics in novel detector development brings you into more science than run-of-the-mill data analysis.